

Day : Tuesday
Date: 3/30/2004

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Time: 14:24:47

Inventor Name Search Result

for SN10/025, 907

Your Search was:

Last Name = JUNG

First Name = YUN-HO

Application#	Patent#	Status	Date Filed	Title	Inventor Name 20
10705891	Not Issued	020 1752	11/13/2003 355/18	MASK FOR LASER IRRADIATION AND APPARATUS FOR LASER CRYSTALLIZATION USING THE SAME	JUNG, YUN-HO IFW unassigned
10704749 Mask (1-4) mask making method (w-17) Lam-ho Jung	Not Issued	020 1752	11/12/2003 255/18 unassigned	MASK FOR LASER IRRADIATION, METHOD OF MANUFACTURING THE SAME, AND APPARATUS FOR LASER CRYSTALLIZATION USING THE SAME	JUNG, YUN-HO IFW
10454679	Not Issued	071 2818	06/05/2003 438/778 Renée Berry	MASK FOR SEQUENTIAL LATERAL SOLIDIFICATION AND CRYSTALLIZATION METHOD USING THEREOF	JUNG, YUN-HO IFW
10211570 20020185659	Not Issued	041 1765	08/05/2002 117/200	LASER ANNEALING APPARATUS F. H. Hershner	JUNG, YUN-HO IFW
10196415	6706545 Issued 6/16/04	150	07/17/2002	METHOD OF FABRICATING A LIQUID CRYSTAL DISPLAY	JUNG, YUN-HO NOT IFW
10163419	Not Issued	041 2818	06/07/2002 438/22	SILICON CRYSTALLIZATION METHOD Phu Dang	JUNG, YUN-HO IFW
10157201 Not Allow - prior art	Not Issued	093 1765	05/30/2002 117/37	SILICON CRYSTALLIZATION METHOD F. H.	JUNG, YUN-HO IFW - no name match
10157199	Not Issued	041 1762	05/30/2002 427/596 EncFaller	AMORPHOUS SILICON DEPOSITION FOR SEQUENTIAL LATERAL SOLIDIFICATION	JUNG, YUN-HO IFW
10151880 Not Allow - unassigned	Not Issued	092 1765	05/22/2002 117/4	METHOD OF CRYSTALLIZING AMORPHOUS SILICON USING A MASK H. F.	JUNG, YUN-HO IFW
10025907	Not Issued	071	12/26/2001	APPARATUS AND METHOD OF CRYSTALLIZING AMORPHOUS SILICON	JUNG, YUN-HO

09697510	6514339	150	10/27/2000	LASER ANNEALING APPARATUS	JUNG, YUN-HO
09697300	6521473	150	10/27/2000	METHOD OF FABRICATING A LIQUID CRYSTAL DISPLAY	JUNG, YUN-HO
09605409	6316338	150	06/28/2000	LASER ANNEALING METHOD	JUNG, YUN-HO
09603883	6346462	150	06/26/2000	METHOD OF FABRICATING A THIN FILM TRANSISTOR	JUNG, YUN-HO
09410093	6335509	150	10/01/1999	LASER ANNEALING APPARATUS	JUNG , YUN-HO
09311702	6177301	150	05/13/1999	METHOD OF FABRICATING THIN FILM TRANSISTORS FOR A LIQUID CRYSTAL DISPLAY	JUNG , YUN-HO
09311700	6326286	150	05/13/1999	METHOD FOR CRYSTALLIZING AMORPHOUS SILICON LAYER	JUNG , YUN-HO
09212709	6537863	150	12/16/1998	LASER BEAM SCANNING METHOD	JUNG , YUN-HO
09210081	6323457	150	12/11/1998	LASER ANNEALING APPARATUS	JUNG , YUN-HO
09143505	6536237	150	08/28/1998	LASER ANNEALING SYSTEM	JUNG , YUN-HO

Inventor Search Completed: No Records to Display.

Search Another: Inventor	Last Name	First Name	
	<input type="text" value="jung"/>	<input type="text" value="yun-ho"/>	<input type="button" value="Search"/>

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	L #	Hits	Search Text	DBs	Time Stamp
1	L1	21	(("6706545") or ("6514339") or ("6521473") or ("6316338") or ("6346462") or ("6335509") or ("6177301") or ("6326286") or ("6537863") or ("6323457") or ("6536237")) .PN.	USPA T; US-P GPUB ; EPO; JPO; DERW ENT; IBM_ TDB	2004/03/3 0 15:07

*goes w/ inventor Name search
for 10/025,907*

	L #	Hits	Search Text	DBs	Time Stamp
1	L1	21	((("6706545") or ("6514339") or ("6521473") or ("6316338") or ("6346462") or ("6335509") or ("6177301") or ("6326286") or ("6537863") or ("6323457") or ("6536237"))).PN.	USPA T; US-P GPUB ; EPO; JPO; DERW ENT; IBM_ TDB	2004/03/3 0 15:08
2	L2	516	(((((427/554,555) or (117/7-10) or (438/487,798,799)).CC LS.) and (laser (light photon)adj (beam ray stream))) and (((427/554,555) or (117/7-10) or (438/487,798,799)).CC LS.) and (".alpha." amorphous)adj (silicon Si) "a-Si"))	USPA T; US-P GPUB ; EPO; JPO; DERW ENT; IBM_ TDB	2004/03/3 0 15:28
3	L3	37957 5	(sequential adj lateral adj solidification) SLS.u/c.	USPA T; US-P GPUB ; EPO; JPO; DERW ENT; IBM_ TDB	2004/03/3 0 15:29
4	L4	17	2 and 3	USPA T; US-P GPUB ; EPO; JPO; DERW ENT; IBM_ TDB	2004/03/3 0 15:29

*EAST Search - update
for 10/025,907*

	L #	Hits	Search Text	DBs	Time Stamp
5	L5	11040	3 and (laser (light photon)adj (beam ray stream))	USPA T; US-P GPUB ; EPO; JPO; DERW ENT; IBM_ TDB	2004/03/3 0 15:30
6	L6	676	3 and ((".alpha." amorphous)adj (silicon Si) "a-Si")	USPA T; US-P GPUB ; EPO; JPO; DERW ENT; IBM_ TDB	2004/03/3 0 15:30
7	L7	5153	(laser (light photon)adj (beam ray stream)) with ((".alpha." amorphous)adj (silicon Si) "a-Si")	USPA T; US-P GPUB ; EPO; JPO; DERW ENT; IBM_ TDB	2004/03/3 0 15:32
8	L8	143	5 and 6 and 7	USPA T; US-P GPUB ; EPO; JPO; DERW ENT; IBM_ TDB	2004/03/3 0 15:32